

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Robert P. Freese et al.

Application No.: 10/661,917

Filed: September 11, 2003

For: SYSTEMS AND METHODS FOR MASTERING MICROSTRUCTURES
THROUGH A SUBSTRATE USING NEGATIVE PHOTORESIST AND
MICROSTRUCTURE MASTERS SO PRODUCED

Confirmation No.: 8346

Group Art Unit: 1756

Examiner: Daborah Chacko Davis

June 23, 2006

Mail Stop Amendment
Commissioner for Patents
Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

The present Amendment is being filed to address the issues raised in the Official Action mailed June 15, 2006.

It is not believed that an extension of time and/or additional fee(s)-including fees for net addition of claims-are required, beyond those that may otherwise be provided for in documents accompanying this paper. In the event, however, that an extension of time is necessary to allow consideration of this paper, such an extension is hereby petitioned under 37 C.F.R. §1.136(a). Any additional fees believed to be due in connection with this paper may be charged to our Deposit Account No. 50-0220.

Amendments to the title begin on Page 2 of this paper.

Amendments to the claims begin on Page 3 of this paper.

Remarks begin on Page 11 of this paper.